

PROCEEDINGS OF SPIE

Laser Beam Shaping XXIII

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Editors

21 August 2023
San Diego, California, United States

Sponsored and Published by
SPIE

Volume 12667

Proceedings of SPIE 0277-786X, V. 12667

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Laser Beam Shaping XXIII, edited by Angela Dudley, Alexander V. Laskin,
Proc. of SPIE Vol. 12667, 1266701 · © 2023 SPIE
0277-786X · doi: 10.1117/12.3012413

Proc. of SPIE Vol. 12667 1266701-1

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Author(s), "Title of Paper," in *Laser Beam Shaping XXIII*, edited by Angela Dudley, Alexander V. Laskin, Proc. of SPIE 12667, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X

ISSN: 1996-756X (electronic)

ISBN: 9781510665484

ISBN: 9781510665491 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA

Telephone +1 360 676 3290 (Pacific Time)

SPIE.org

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